

<b>Notice of References Cited</b>	Application/Control No. 10/642,706	Applicant(s)/Patent Under Reexamination CHIA ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0182911	09-2004	Chia et al.	228/180.5
	B	US-6,670,214	12-2003	Chia et al.	438/106
	C	US-6,046,075	04-2000	Manteghi, Kamran	438/123
	D	US-5,795,818	08-1998	Marrs, Robert C.	438/612
	E	US-5,396,104	03-1995	Kimura, Masao	257/784
	F	US-5,285,949	02-1994	Okikawa et al.	228/179.1
	G	US-4,002,282	01-1977	Murdoch, Francis J.	228/4.5
	H	US-5,950,100	09-1999	Shingai, Tadayuki	438/617
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP-361269319A	11-1986	JP	Tanimoto et al.	
	O	JP-08288330A	11-1996	JP		
	P	JP-401105553A	04-1989	JP	Kawai et al.	
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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